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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Luo et al.

Serial No.: 10/826,985

Filed: April 19, 2004

For: METHODS FOR FORMING
PROTECTIVE LAYERS ON
SEMICONDUCTOR DEVICE COMPONENTS
SO AS TO REDUCE OR ELIMINATE THE
OCCURENCE OF DELAMINATION THEREOF
AND CRACKING THEREIN

Confirmation No.: 3493

Examiner: J. Stark

Group Art Unit: 2823

Attorney Docket No.: 2269-5565.1US
(02-1124.01/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

February 8, 2007
Date

Signature

Erika Gandre
Name (Type/Print)

RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Examiner:

This Response follows the final Office Action of January 23, 2007, the shortened statutory period for response to which expires on April 23, 2007. This Response is being submitted within two months of the mailing date of the final Office Action.